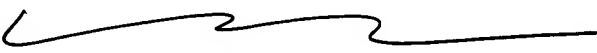
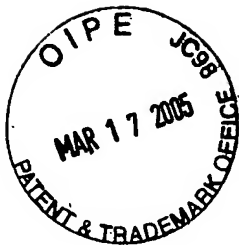


IFW

<b>TRANSMITTAL LETTER</b> (General - Patent Pending)				Docket No. SEC.1081	
In Re Application Of: Ju-bum LEE					
Application No. 10/782,783	Filing Date February 23, 2004	Examiner Anh D. MAI	Customer No. 20987	Group Art Unit 2814	Confirmation No. 5507
Title: METHOD FOR MANUFACTURING A SEMICONDUCTOR DEVICE					
<u>COMMISSIONER FOR PATENTS:</u>					
Transmitted herewith is:  <b>Response to Restriction Requirement</b>					
in the above identified application.					
<input checked="" type="checkbox"/> No additional fee is required. <input type="checkbox"/> A check in the amount of _____ is attached. <input checked="" type="checkbox"/> The Director is hereby authorized to charge and credit Deposit Account No. 50-0238 as described below. <input type="checkbox"/> Charge the amount of _____ <input checked="" type="checkbox"/> Credit any overpayment. <input checked="" type="checkbox"/> Charge any additional fee required. <input type="checkbox"/> Payment by credit card. Form PTO-2038 is attached.					
<b>WARNING: Information on this form may become public. Credit card information should not be included on this form. Provide credit card information and authorization on PTO-2038.</b>					
 _____ Signature			Dated: March 17, 2005		
LINUS Y. PARK Reg. No. 45,261 Volentine Francos & Whitt, P.L.L.C. One Freedom Square 11951 Freedom Drive, Suite 1260 Reston, VA 20191 Tel. No. (571) 283-0720			<div style="border: 1px solid black; padding: 5px;">I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to the "Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450" [37 CFR 1.8(a)] on _____. (Date)  _____ Signature of Person Mailing Correspondence  _____ Typed or Printed Name of Person Mailing Correspondence</div>		
CC:					



Application No. 10/782,783  
SEC.1081  
Response filed on March 17, 2005

*IN THE UNITED STATES PATENT AND TRADEMARK OFFICE*

In re PATENT APPLICATION of :  
Ju-bum LEE : Group Art Unit 2814  
Application No. 10/782,783 : Examiner Anh D. MAI  
Filed February 23, 2004 :

METHOD FOR MANUFACTURING A SEMICONDUCTOR DEVICE

**RESPONSE TO ELECTION/ RESTRICTION**

U.S. Patent and Trademark Office  
**Customer Window, Mail Stop Amendment**  
Randolph Building  
401 Dulany Street  
Alexandria, VA 22314

Sir:

In response to the Office Action dated February 22, 2005, the following remarks are respectfully submitted in connection to the above identified application.

**Remarks/Arguments** begin on page 2 of this paper.